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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of:

Inventors: Moriguchi et al.

Serial No.: 10/602,266

Filed: June 23, 2003

Title: GRAIN-FREE POLYCRYSTAL-
LINE SILICON AND METHOD)
FOR PRODUCING SAME



) ATTORNEY FILE NO.:
SLA0770

) Examiner: Padgett,
Marianne L.

) Customer No.: 55,286
) Confirmation No.: 1706

) Group Art: 1762

Mail Stop Amendments
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

CERTIFICATION UNDER 37 CFR § 1.8

I hereby certify that the documents referred to as enclosed herein are being deposited with the United States Postal Service as first class mail on, or before this date 11/21/2006, in an envelope addressed to: Mail Stop Amendments, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Date

11/20/2006

Signature

RESPONSE UNDER 37 CFR 1.111

In response to an Office Action mailed September 19, 2006,
please amend and reconsider the above-referenced application as follows.

Amendments to the specification are presented beginning on
page 2 of this paper.

Amendments to the claims begin at page 4 of this paper.

Remarks begin at page 17 of this paper.

Replacement drawings are enclosed.

A Terminal Disclaimer is enclosed.

A PTO-2038 credit authorization form is enclosed to cover
the cost of the Terminal Disclaimer.